## Security Evaluation Against Electromagnetic Analysis at Design Time

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- Motivation
- Simulation methodology for EMA
  - System partitioning
  - Simulation flow
  - Types of EM emissions
  - EMA measurement equipment
- Results
- Conclusion





## **Motivation**

Post-manufacture test:

- Time consuming
- Error prone
- Expensive
- So that has driven the study of designtime security evaluation



- EM Simulation -- Solve Maxwell's Equations for simulating wave propagation
  - Pro: accurate
  - Con: computationally complex, timeconsuming

# EMA measurement equipment

• Near-field  $(r < \lambda/2\pi)$  electric field sensors

 $E \propto I$ 

Near-field magnetic field sensors

 $B \propto I$ 

• Far-field  $(r > \lambda/2\pi)$  electromagnetic field sensors

$$emf \propto I$$



- Circuit Simulation solve for V & I according to Kirchhoff's voltage and current laws
  - Pro: fast
  - Con: accuracy limited by the accuracy of lumped element models; validity limited by range of frequencies, geometries etc





## EM analysis simulation procedure



# EMA measurement equipment

• Near-field  $(r < \lambda/2\pi)$  electric field sensors

$$E \propto I$$

- Near-field magnetic field sensors  $B \propto I$   $V \propto \frac{dB}{dt} \propto \frac{dI}{dt}$
- Far-field  $(r > \lambda/2\pi)$  electromagnetic field sensors

$$emf \propto I$$

# Types of EM emissions

Direct Emissions

- Modulated Emissions
  - Amplitude Modulation
  - Angle Modulation (phase or frequency)

## Simulation setup – Springbank test chip



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### Simulation results

- -- synchronous XAP processor
- -- inductive sensor



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#### EM measurement results

- -- synchronous XAP processor
- -- inductive sensor



### Simulation results

- -- dual-rail asynchronous XAP processor
- -- inductive sensor



#### EM measurement results

- -- dual-rail asynchronous XAP processor
- -- inductive sensor



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### Simulation results

- -- dual-rail asynchronous XAP processor
- -- inductive sensor modulated emission



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# How time shift affects AM modulation and demodulation



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# How time shift affects AM modulation and demodulation



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- A simulation methodology for EMA has been proposed
  - EM simulator for modelling Package and PCB
  - Circuit simulator for simulating EMA of chip+ package +PCB
  - Data processing for EM analysis according to
    - sensor types (ouput ∝ di/dt or ∝ i)
    - EM emission types (direct or modulated)

# Conclusion cont.

- The results also indicates that
  - The synchronous processor under test has data dependent EM emissions

 The asynchronous processor under test has less data dependent EM emissions in direct EMA test, but demonstrated more data dependent EM emissions in modulated EMA test



# Thank You!